MAY 2 3 2005



Fax transmission from:

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Date:	05/23/2005	Cove	er Sheet + Pages
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RE: Patent Application No.: 10/631,215			
Filed: 08/01/2003			\$ 20 M 19 M
Inventor: Piqué et al.			
]I	Oocket No.: NC 84,952	• • • • • • •	
Amendment after Non-Final Rejection – 6 pages			
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PATENT APPLICATION Docket No.: NC 84,952

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Pique et al.

Serial No.: 10/613,215 Filed: 08/01/2003

For: DIRECT-WRITE LASER TRANSFER AND PROCESSING

Examiner: Bueker, Richard R.

Art Group Unit: 1763

Honorable Commissioner of Patents

PO Box 1450

Alexandria, VA 22313-1450

May 23, 2005

AMENDMENT IN RESPONSE TO NON-FINAL REJECTION

Sir:

In response to the Office action of 03/09/2005 setting a three month shortened statutory period of reply, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

CERTIFICATE OF FASCMILE TRANSMISSION

I certify that this correspondence is being facsimile transmitted to the US Patent and Trademark Office on the date shown below.

5/23/05

Date

Joseph T. Grunkemeyer